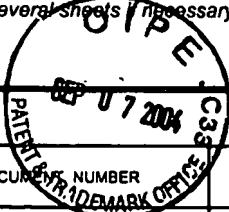


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*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

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						YES	NO

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/RK/		IBM Technical Disclosure Bulletin, FABRICATION PROCESS FOR GAS DISCHARGE PANELS by M. Berkenblit et al., Vol. 18, No. 6, November 1975, 2 pages
		EPITAXIAL GROWTH, Part A, edited by JW Matthews, IBM Thomas J. Watson Research Center, New York, Pages 91-99
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